

Notice of References Cited	Application/Control No. 10/757,830	Applicant(s)/Patent Under Reexamination YEH ET AL.	
	Examiner Andy Huynh	Art Unit 2818	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,157,058	12-2000	Ogura, Seiki	257/315
	B	US-5,638,320	06-1997	Wong et al.	365/185.03
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	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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